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Dated: August 2, 2008

Signature

Lawrence E. Russ

EXPEDITED PROCEDURE

Group Art Unit: 2811

Docket No.: VELOX 3.0-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

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Pophristic et al.

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Application No.: 10/780,526

: Group Art Unit: 2811

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: Examiner: S. A.

: Gebremariam

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For: LOW DOPED LAYER FOR NITRIDE-BASED SEMICONDUCTOR DEVICE

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AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 3, 2006, finally rejecting claims 1-17, 19-36, and 71-73, please amend the above-identified U.S. patent application as follows: